

<b>Notice of References Cited</b>	Application/Control No. 10/826,504		Applicant(s)/Patent Under Reexamination LOGVIN ET AL.	
	Examiner Derek L. Dupuis		Art Unit 2883	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0076188 A1	06-2002	Kimerling et al.	385/132
*	B	US-4,810,049	03-1989	Fischer et al.	385/132
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Popovic et al., "Air Rencches for Sharp Silica Waveguide Bends", Journal of Lightwave Technology, Vol. 20, No. 9, September 2002 (cited in IDS)
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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